

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Date Submitted: August 13, 2002

*(use as many sheets as necessary)*

1	of	1
---	----	---

**Complete if Known**

<b>Application Number</b>	10/044,964
<b>Filing Date</b>	01/15/2002
<b>First Named Inventor</b>	Sumio OGAWA et al.
<b>Group Art Unit</b>	2121
<b>Examiner Name</b>	Unassigned
<b>Attorney Docket Number</b>	088941-0203

Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
	A1	6,143,584		FUKADA et al.	11/07/2000	<div style="text-align: center;"> <b>RECEIVED</b>  <b>AUG 14 2002</b>  <b>Technology Center 2100</b> </div>
	A2	5,294,812		HASHIMOTO et al.	03/15/1994	
	A3	5,844,850		TSUTSUI et al.	12/01/1998	
	A4	5,963,881		KAHN et al.	10/05/1999	
	A5	5,497,381		O'DONOGHUE et al.	03/05/1996	
	A6	5,301,143		OHRI et al.	04/05/1994	

[illegible]

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>6</sup>
	A7	SEIICHIRO, "Semiconductor Device and its Manufacture," Patent Abstracts of Japan, Vol. 1999, No. 5, May 31, 1999, JP 11 045839, February 16, 1999, Denso Corp., Abstract.	
	A8	KIBARIAN et al., "Using Spatial Information to Analyze Correlations Between Test Structure Data," IEEE Transactions on Semiconductor Manufacturing, Vol. 4, No. 3, August 1991, pages 219-225, XP002201314.	

**Examiner  
Signature**

Date  
Considered

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Unique citation designation number. 2See attached Kinds of U.S. Patent Documents. 3Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

5Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6Applicant is to place a check mark here if English language Translation is attached.

**Burden Hour Statement:** This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, D.C. 20231. **DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO:** Assistant Commissioner for Patents, Washington, D.C. 20231.



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ATTORNEY DOCKET NO. 088941-0203

Handwritten notes: 1/14/03, 5/14/03, and initials.

Applicant: Sumio OGAWA et al.

Title: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICES

Appl. No.: 10/044,964

Filing Date: 01/15/2002

Examiner: Unassigned

Art Unit: 2121

RECEIVED

AUG 14 2002

Technology Center 2100

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR §1.56**

Commissioner for Patents  
Box PATENT APPLICATION  
Washington, D.C. 20231

RECEIVED  
JAN 15 2003  
TC 2800 MAIL ROOM

Sir:

Submitted herewith on Form PTO/SB/08 is a listing of documents known to Applicants in order to comply with Applicants' duty of disclosure pursuant to 37 CFR §1.56. A copy of each listed document is being submitted to comply with the provisions of 37 CFR §1.97 and §1.98.

The submission of any document herewith, which is not a statutory bar, is not intended as an admission that such document constitutes prior art against the claims of the present application or that such document is considered material to patentability as defined in 37 CFR §1.56(b). Applicants do not waive any rights to take any action which would be appropriate to antedate or otherwise remove as a competent reference any document which is determined to be a *prima facie* art reference against the claims of the present application.

**TIMING OF THE DISCLOSURE**

The listed documents are being submitted in compliance with 37 CFR §1.97(c), before the mailing date of the first Office Action on the merits.

**RELEVANCE OF EACH DOCUMENT**

Document A1 is an English equivalent of the Japanese application set forth in the Patent Abstract of Document A7.

Documents A2-A8 came to Applicants' attention during a search of the corresponding European application. A copy of the Partial European Search Report setting forth the portion of each reference considered relevant by the examiner is attached.

Applicants respectfully request that any listed document be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO/SB/08 be returned in accordance with MPEP §609.

**STATEMENT**

The undersigned hereby states in accordance with 37 C.F.R. §1.97(e)(1) that each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to filing of this Statement.

The Commissioner is hereby authorized to charge any additional fees which may be required regarding this application under 37 CFR §§ 1.16-1.17, or credit any overpayment, to Deposit Account No. 19-0741. Should no proper payment be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 19-0741.

August 13, 2002  
Date

FOLEY & LARDNER  
Customer Number: 22428



22428

PATENT TRADEMARK OFFICE

Telephone: (202) 672-5407

Facsimile: (202) 672-5399

Respectfully submitted,

*Michael M. Blumenthal*

*Reg No. 34,717*

*for*

David A. Blumenthal  
Attorney for Applicant  
Registration No. 26,257